Application of MZI Symmetrical Structure With Fiber Balls and Seven-Core Fiber in Microdisplacement Measurement

Liming ZHAO¹, Hong LI^{1,3}, Yanming SONG¹, Mingli DONG^{2*}, and Lianging ZHU^{1,3*}

Abstract: An optical fiber microdisplacement sensor based on symmetric Mach-Zehnder interferometer (MZI) with a seven-core fiber and two single-mode fiber balls is proposed. The rationality and manufacturing process of the MZI sensing structure are analyzed. The fabrication mechanism of the Mach-Zehnder sensor by CO₂ laser is described in detail. Experimental results show that temperature sensitivities of the two dips are 98.65 pm/°C and 89.72 pm/°C, respectively. The microdisplacement sensitivities are 2017.71 pm/mm and 2457.92 pm/mm, respectively. The simultaneous measurement of temperature and microdisplacement is demonstrated based on the sensitive matrix. The proposed Mach-Zehnder interference sensor exhibits the advantages of compact structure, simple manufacturing process, and high reliability.

Keywords: Microdisplacement; Mach-Zehnder interferometer; fiber ball; symmetrical structure; seven-core fiber

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1. Introduction

Microdisplacement have wide sensors applications in automatic equipment, robots, and road and bridge management [1-6]. High precision displacement sensors include the displacement sensor [2], capacitive displacement sensor [3], photoelectric displacement sensor [4, 5], ultrasonic displacement sensor [6], and so on. With the development of optical fiber technology, many optical fiber displacement sensors have emerged. Generally, the optical fiber sensor has many advantages, such as small size, light weight, electromagnetic immunity, and good link-reusability [7]. On the basis of the above advantages, the optical fiber displacement sensor has quickly won the favor of many researchers.

Fiber sensor could solve many problems of the displacement measurement in severe environment. In 2012, Zhong et al. [8] designed the fiber Bragg grating (FBG) displacement sensor which is based on the double-trapezoidal cantilever beam structure with the displacement sensitivity of 0.25 nm/mm. In addition to the existing cantilever beam structure, the deformation ring structure is also a hot research topic. Compared with cantilever beam structure, it

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has higher measuring precision. In 2018, Shangguan et al. [9] designed an optical fiber Fabry-Perot sensor based on hydrofluoric acid corrosion, and the displacement sensitivity of the sensor can reach $0.0100 \text{ nm/}\mu\text{m}$ within the range of $0 \mu\text{m}-1000 \mu\text{m}$ displacement at room temperature. As a kind of fiber optic sensor, Mach-Zehnder interferometer (MZI) fiber optic sensor has the characteristics of simple structure, portability, easy manufacture, sensitivity, and large sensing wavelength range. MZ interference micro-displacement sensor has been widely studied [10-12]. In 2013, Chen et al. [13] proposed a micro-displacement sensor with a core-offset structure. Its microdisplacement sensitivity is 0.835 nm/µm. The core-offset structure is very sensitive to temperature, so the experimental result is easily affected by temperature. In 2013, Shen et al. [14] put forward a microdisplacement sensor based on an MZI made of a bowknot type taper. Experimental results show that microdisplacement sensitivity is 1.93 dB/µm and the temperature sensitivity is $0.023 \text{ dB/}^{\circ}\text{C}$, so the cross-sensitivity effect on the proposed sensor can be neglected in practical applications. But it cannot realize the measurement of temperature and microdisplacement simultaneously. In recent researches, the fiber Bragg grating has been combined with an MZI in order to achieve the simultaneous measurement of temperature and micro displacement (or strain and other parameters). In 2017, Zhou et al. [15] proposed a single-mode and multimode temperature sensing structure which can measure temperature 800 °C accurately. Compared with the traditional sensor, the sensitivity and the measuring range have been greatly improved. The structure needs to reasonably control the multi-mode optical fiber welding parameters, higher requirements for machining process and the displacement measurement which has not been realized.

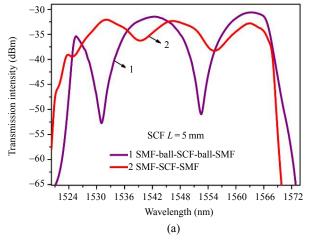
In this paper, an optical fiber microdisplacement sensor based on symmetric Mach-Zehnder interferometer with a seven-core fiber and two single-mode fiber balls is proposed. Based on its good sensing characteristics and good response sensitivity, the sensor has great potential in the direction of microdisplacement measurement. In Section 2, the rationality of the sensing structure is analyzed. Moreover, the manufacturing process and sensing principle of the sensing structure are described in detail. The role of the sensing structure in MZI sensing is also explained. In Section 3, the sensor sensing characteristic experiment, including temperature characteristic test and microdisplacement characteristic test, is completed. The experimental results are analyzed as well. In Section 4, a discussion and some conclusions are finally made.

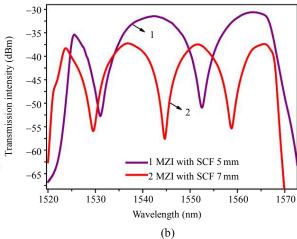
2. Sensor structure and principle

2.1 Sensor design

We have spliced the seven-core fiber (SCF) with different lengths between two segments of single mode fibers (SMFs) to construct the SMF-SCF-SMF structure (i.e. without two fiber balls). However, the interferometer can't be formed or the response is weak. Figure 1 shows the transmission spectra of different structure MZIs.

As shown in Fig. 1(a), the purple line is the spectrum of the MZI with 5 mm length SCF and two fiber balls structure, and the red line is the spectrum of the MZI with only 5 mm length SCF without fiber ball. It can be seen that the No. 1 MZI interference fringe has a visibility around 20 dB much more than No. 2 has. The coupling effects of fiber ball structure can help the interference enhancement of multi-core fiber (MCF). Figure 1(b) shows the transmission spectra of the proposed MZI with the lengths of 5 mm and 7 mm SCFs. The intensity of the interference light exhibits a certain periodicity as a function of wavelength, also it is shown that the sensor's free spectrum range increases as the SCF length L decreases. The experimental results in Fig. 1(b) will be followed by detailed theoretical derivation.





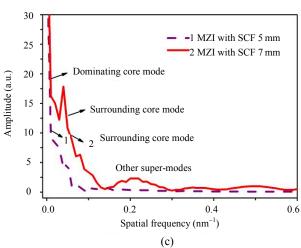


Fig. 1 Measured transmission spectra of the MZIs: (a) different MZI structures, (b) different lengths with two fiber balls, and (c) spatial frequency by FFT for the transmission spectra of the different MZI structures.

To understand clearly the number and the power distribution of the interference modes, the transmission spectrum [illustrated in Fig. 1(b)] is

achieved by fast Fourier transform (FFT) to get the spatial frequency spectrum, as shown in Fig. 1(c). It can be observed that one interference peak appears in the spatial spectrum, which is formed due to the interference between the dominating core mode and the surrounding core modes. The dominated peak of the dotted line is situated at the frequency of 0.0501 nm⁻¹, in which the solid line is 0.0400 nm⁻¹. It is the fact that other super-modes are also possibly excited, which results in some smaller spatial frequency peaks.

As shown in Fig. 2, the light filed propagation and intensity distribution of the SMF-ball-SMFball-SMF [Fig. 2(a)] and SMF-ball-SCF-ball-SMF [Figs. 2(b)–2(d)] are simulated by beam propagation. In the simulation, lengths of SMF and SCF are maintained in the same of 7 mm, and the diameters of balls are adjusted for 0.3 mm, 0.4 mm, and 0.5 mm, respectively. It can be seen from Fig. 2(a) that the intensity of the light field is mainly distributed in the central core and the coupling efficiency with light is low. In the SMF-ball-SCF-ball-SMF structure, the light can be better coupled from the lead-in SMF into the seven-core fiber because of the ball of SMF. As shown in Fig. 2(b), the intensity of the light field is not only distributed in the central core, but also distributed in other cores and cladding of the SCF when the diameter of ball is 300 µm. From Figs. 2(c) and 2(d), we can get that the change of single-mode fiber balls' diameter will have a certain impact on the output intensity of the light field.

From the simulation results, it can be concluded that the energy change and the final output energy are different when the diameters of the single-mode fiber balls in the middle section are different. According to this simulation, the diameters of the single-mode fiber balls which are suitable for this paper can be selected to obtain good coupling efficiency. By analyzing the three figures [Figs. 2(b)–2(d)], the intensity of the light field coupled from the fiber balls to the core of the output SMF is

stronger when the diameter of the single-mode fiber balls is $400\,\mu m$. In this case, a better transmission spectrum can be formed which is more conducive to the analysis of experimental results. In the

subsequent research process, the researchers could choose an appropriate size of the seven-core fiber and the single-mode fiber balls as an important part of the MZI sensor.

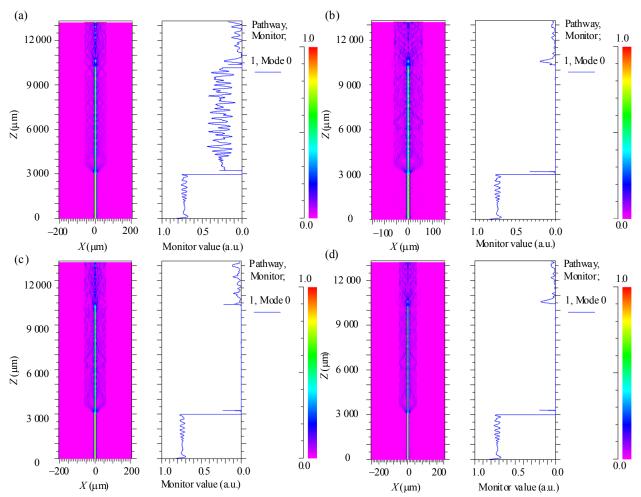


Fig. 2 Light propagation along the ball-SMF-ball and ball-SCF-ball structure: (a) the structure of SMF-ball-SMF with the ball of $400\,\mu m$, (b) the structure of SMF-ball-SCF-ball-SMF with the ball of $400\,\mu m$, (c) the structure of SMF-ball-SCF-ball-SMF with the ball of $400\,\mu m$, and (d) the structure of SMF-ball-SCF-ball-SMF with the ball of $500\,\mu m$.

2.2 Sensor fabrication

The structure of the full fiber MZI sensor based on the SCF and the optical fiber fusion ball is shown in Fig. 3. The fabrication procedures are able to achieve by a glass processing and splicing system (AFL Fujikura, LZM-100 LaserMaster) in Ball Lens Menu, which is selected in the FPS software supporting the LZM-100. The splicing system uses a CO₂ laser as the heating source to soften fibers due to its cleanness, low maintenance, and long-term

consistency, which can ensure repeatable performance. The laser beam path of the fusion splicer is shown in Fig. 3(a). The maximum power of the CO₂ laser is 30 W. After passing a safety shutter and a reflecting mirror, the laser beam is split into two paths to heat fiber on opposite sides with an angle about 170° to avoid coupling, which ensures that the fiber transverse section can be heated uniformly. A shutter is used to modulate the laser. The fiber processing machine could show the hot images of the fiber and the information of the laser

during the process by the charge coupled devices (CCDs) and the thermal piles. The beam path is adjusted by the mirrors mounted on the mechanical tunable fixtures. The remaining laser power is completely absorbed by 2 thermal piles for safety, measurement of power, beam size, and beam position. The beam power should be aligned to the fiber and ensure the camera for a good measurement

accuracy. The fusion splicer has a pair of rotation motors mounted on the left and right translation motors respectively, which rotates with no restriction. A pair of fiber holders is fixed on the rotation motors. The fiber is homogeneously exposed to the laser from both sides of the fiber deflector. The formation of an MZI structure with a CO_2 laser splicer is shown in Fig. 3(b).

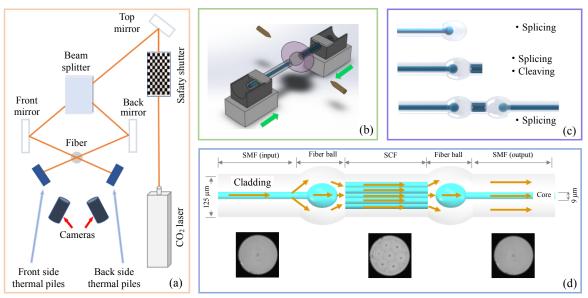


Fig. 3 Structure of the full fiber MZI sensor based on the SCF and the optical fiber fusion ball: (a) laser beam path of the fusion splicer, (b) formation of MZI structure, (c) processing program of MZI, and (d) sensing structure diagram.

We set the proposed MZI processing program, which consists of the following steps:

Step 1: The fiber balls used in the symmetrical structure here are prepared beforehand by splicing at one end of an SMF. As shown in Fig. 3(c), the fiber is fixed on the right holder, and the two beams of the CO₂ laser are focused on the end of the fiber. Both the rotation and translation movements must operate synchronously. To obtain a specific diameter fiber ball, the translation speed should match with the rotation speed rationally. The rotation motor should twist 360° at 150°/s when the translation motors run at 0.05 mm/s feeding speed. The fiber ball structure about 400 µm diameter is obtained.

Step 2: Cleave the end of seven-core fiber and splice the flat end with the fiber ball [Fig. 3(d)]. Then cleave the other end of seven-core fiber again

and make a section of 7 mm length SCF retained.

Step 3: Splice the structure fabricated at Step 2 with another fiber ball, forming "SMF-ball-SCF-ball-the SMF" optical waveguide, then the in-line fiber MZI structure is completed, as shown in Fig. 3(d).

The parameters of the program for fabricating the MZI structure are listed in Table 1.

Table 1 Parameters of the program for fabricating the MZI structure.

Parameters	Value
Fiber diameter	125 μm
Ball diameter	$400\mu m$
Strip length	17 mm
Pre-heat time	5 s
Lens creation power	762 bits
Lens type	Cylindrical lens
Rotator speed	150 deg/s
Feeding speed	0.05 mm/s

2.3 Sensing principle

In the SCF, the optical path differences are due to the effective refractive index differences among the central core mode, the surrounding core mode, and the cladding modes. Generally, each optical path difference induced by the combination of these modes could generate either interference weak or strong interference (depending on the intensity of the involved modes). Here, we only consider the dominant interference caused by the optical path difference (OPD) induced by the central core mode and the surrounding core mode of the MCF [16], so this structure still can be regarded as an MZI model [17], then the transmission spectrum intensity of the proposed interferometer can be explained as

$$I = I_c + I_s + 2\sqrt{I_c I_s} \cos \Delta \Phi \tag{1}$$

where I_c is the central core mode intensity, I_s is the surrounding core mode intensity of the SCF, and $\Delta \Phi$ is the phase difference between the core mode and the surrounding core mode, which can be defined as

$$\Delta \varphi = \frac{2\pi \Delta n_{\rm eff} L}{\lambda_{\rm p}} \tag{2}$$

where λ_0 is the wavelength of the propagating light, $\Delta n_{\rm eff}$ is the effective refractive index (ERI) coefficient difference between the core mode and the surrounding core mode, and L is the interaction length of SCF between the ball-shape fiber structures, namely, the length of interferometer arm. If phase difference satisfies the condition $\Delta \Phi = (2m+1)\pi$, $m=1, 2, 3, \cdots$, the intensity of transmission reaches its valley value at the wavelength as follows:

$$\lambda_m = \frac{2\Delta n_{\text{eff}} L}{2m+1}.$$
 (3)

The initial transmission spectrum of the interference structure acquired by a wide spectrum source and spectrometer is shown in Fig. 4.

The length of interferometer arm and the ERI of the *m*-order attenuation peak would be changed by the external environment parameters, such as temperature, strain, and refractive index, which further brings about shifts of the interference fringes. So, the measured value can be determined by monitoring the transmission spectrum.

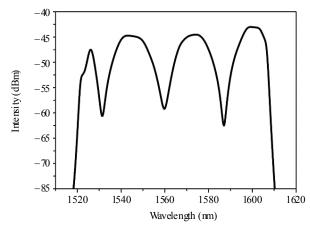


Fig. 4 Initial transmission spectrum.

Also from (3), the free spectral range (FSR) of the interference fringe pattern is determined by the optical path difference, $\Delta n_{\text{eff}}L$, which can be approximated by [18] follows:

$$FSR = \left| \lambda_m - \lambda_{m-1} \right| = \frac{4\Delta n_{\text{eff}} L}{(2m+1)(2m-1)}$$

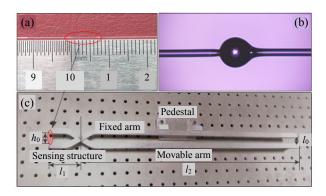
$$= \frac{\lambda_m^2}{\Delta n_{\text{eff}} L} \cdot \frac{2m+1}{2m-1} \approx \frac{\lambda_m^2}{\Delta n_{\text{eff}} L}.$$
(4)

The FSR determines the density of the comb-like transmission spectrum. It can be seen that the FSR will decrease with interferometer length *L*.

Figure 5 shows the schematic structure of the microdisplacement measurement device. According to the principle of leverage, the actual lengths of the lever arms are l_4 and l_5 . When the movable arm turns around an angle of $2\Delta\theta$ while the fixed arm remains stationary, it can be equivalent to the two arms rotating at an angle of $\Delta\theta$ at the same time, as shown by the blue line in Fig. 5(d).

The right triangle is constructed, and three equations, $C = \theta_{10} - \theta_{20}$ (C is a constant), $\theta_1 = \theta_{10} + \Delta \theta$, and $\theta_2 = \theta_{20} + \Delta \theta$ are defined, where θ_1 is the angle between l_4 and the central axis, θ_2 is the angle between l_5 and the central axis, and θ_{10} and θ_{20} are the initial states of θ_1 and θ_2 , respectively. And $\Delta \theta$ is the angle of the arms turned.

We can easily get $\sin \theta_1 = h/2l_4$ and $l = 2l_5 \sin \theta_2$ through the mathematical analysis of Fig. 5(d).



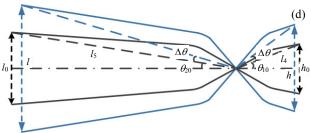


Fig. 5 Schematic structure of the microdisplacement measurement device: (a) sensing structure, (b) melting ball physical map, (c) the side sectional view of the microdisplacement measurement device, and (d) schematic structure of the micro-displacement measurement device.

Then (5) is achieved by substituting $C = \theta_{10} - \theta_{20}$, $\theta_1 = \theta_{10} + \Delta\theta$, $\theta_2 = \theta_{20} + \Delta\theta$, and $\sin\theta_1 = h/2l_4$ into $l = 2l_5\sin\theta_2$.

$$l = \frac{l_5 \cos C}{l_4} h - \frac{2l_5 \sin C}{l_4} \sqrt{l_4^2 - (h/2)^2} .$$
 (5)

In the microdisplacement experiment, l changes from the initial value l_0 with a step of 0.12 mm. The overall variation of l is 1.08 mm, in which the microdisplacement at the other end of the arm is so small compared with l_4 (5.85 cm) that $\sqrt{l_4^2 - (h/2)^2}$ can be regarded as a fixed value $\sqrt{l_4^2 - (h_0/2)^2}$. Then, (5) can be written as (6) as follows:

$$l = \frac{l_5 \cos C}{l_4} h - \frac{2l_5 \sin C}{l_4} \sqrt{l_4^2 - (h_0 / 2)^2} .$$
 (6)

Therefore, l rises in approximate linearity with an increase in h in the experimental range. Assuming that the elongation of the micrometer caliper is Δl , the arc length swept by the arms can be nearly regarded as the chord length. The equation

$$\Delta h = \frac{l_4}{l_5 \cos C} \Delta l \quad \text{can be easily got. The axial}$$
microdisplacement is in the sensor part can be

microdisplacement ε in the sensor part can be calculated from (6) and shown in (7) as follows:

$$\varepsilon = \frac{\Delta h}{h_0} = \frac{l_4}{l_5 h_0 \cos C} \Delta l \ . \tag{7}$$

When the ambient temperature of the optical fiber changes, the sensitivity of the characteristic wavelength of the valley in the transmission spectrum can be expressed as [19]

$$\frac{\partial \lambda_{m}}{\partial T} = \frac{2}{2m+1} \left[\Delta n_{\text{eff}} \frac{\partial L}{\partial T} + L \left(\frac{\partial n_{\text{co}}^{\text{eff}}}{\partial T} - \frac{\partial n_{\text{cl},j}^{\text{eff}}}{\partial T} \right) \right]$$
(8)

where $\Delta n_{\rm eff}$ represents the effective refractive index between the fiber core module and the *j*-order cladding module, and $\Delta n_{\rm eff} = n_{\rm co}^{\rm eff} - n_{{\rm cl},j}^{\rm eff}$, *T* indicates temperature.

When the axial microdisplacement ε of the fiber is changed, the sensitivity of the characteristic wavelength of the valley in the transmission spectrum can be expressed as follows [19]:

$$\frac{\partial \lambda_{m}}{\partial \varepsilon} = \frac{2}{2m+1} \left[\Delta n_{\text{eff}} \frac{\partial L}{\partial \varepsilon} + L \left(\frac{\partial n_{\text{co}}^{\text{eff}}}{\partial \varepsilon} - \frac{\partial n_{\text{cl},j}^{\text{eff}}}{\partial \varepsilon} \right) \right]. \quad (9)$$

From (8) and (9), the wavelength value of the wave valley in the interference spectrum is in the different proportion to the changes of temperature and microdisplacement, that is, the response sensitivities to temperature and microdisplacement are different. Therefore, temperature and microdisplacement can be measured simultaneously by the wavelength shift of the valley of the transmission spectrum and the sensitivity coefficient matrix.

3. Experiment

The experimental system is shown in Fig. 6, including a light source with a flat output in the range from 1516.30 nm to 1616.30 nm and an OSA (AQ6370C) with a wavelength resolution of 0.05 nm. In the application of Mach-Zehnder interference sensor, there is always a problem of cross sensitivity. When sensing, it is difficult to distinguish the changes of measured quantities caused by

microdisplacement and temperature. Therefore, the temperature characteristic of the sensor structure should be analyzed before the microdisplacement experiment.

3.1 Temperature characteristic experiment

For the temperature characteristic experiment, the sensor head is placed into the thermostatic heater plate and then the temperature is allowed to rise from 27.9 $^{\circ}\mathrm{C}$ to 119.5 $^{\circ}\mathrm{C}$. The temperature characteristic test platform is shown in Fig. 6. The shifts of the two dips are recorded about 10 $^{\circ}\mathrm{C}$. The output spectra and temperature response characteristics curve are shown in Fig. 7.

From Fig. 7(a), both the dip shifts to the long wavelength with temperature rising and the shift of Dip 1 and Dip 2 are more intuitive. As can be seen from Fig. 7, compared with the change of light intensity, the linearity of the drift amount of the wavelength is better, so the drift amount will be analyzed next. As shown in Fig. 7(b), Dip 1 moves from 1559.7580 nm to 1568.7939 nm, with a sensitivity of 98.65 pm/°C, meanwhile, Dip 2 moves from 1586.9838 nm to 1595.2024 nm, with a sensitivity of 89.72 pm/°C.

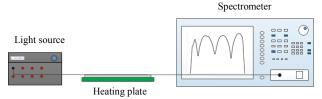


Fig. 6 Temperature characteristic test platform.

3.2 Microdisplacement experiment

The experimental for setup the microdisplacement measurement is shown in Fig. 5(a). The lever structure is made by aluminum. The sensing structure is pasted to the end of the short arms with epoxy resin named DP420. Based on the laboratory experience and characteristic of the sensor, DP420 epoxy resin glue, a kind of adhesive agent with good insulating properties, small after curing shrinkage shape variables, and mechanical strength, is chosen. Usually, to be solidified, it needs over 12 hours under room temperature or shorter by heating. The sensor structure is initially in a natural straightening state.

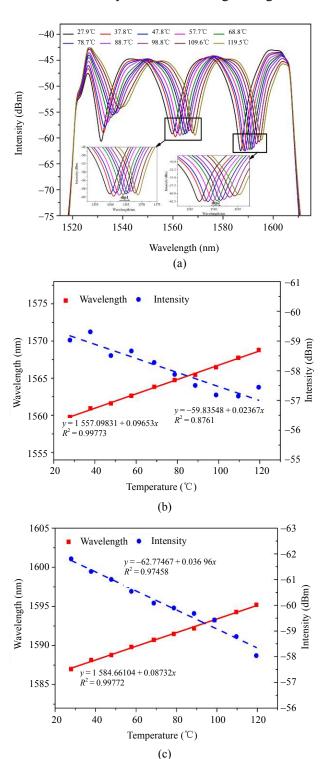


Fig. 7 Temperature characteristic experiment results: (a) experimental transmission spectra with different temperatures, (b) relationship between temperature and wavelength shift of Dip 1, and (c) relationship between temperature and wavelength shift of Dip 2.

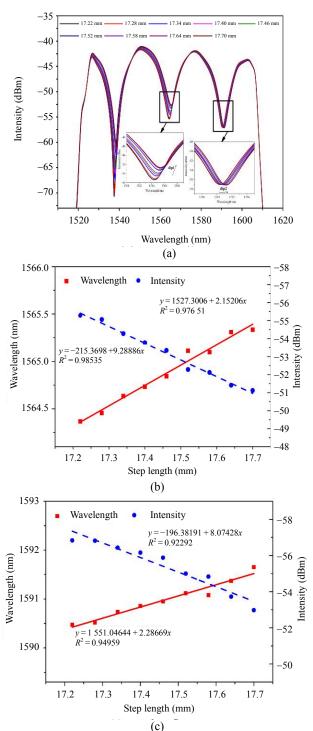


Fig. 8 Microdisplacement experimental results: (a) experimental transmission spectra with different step lengths, (b) relationship between step length and wavelength shift of Dip 1, and (c) relationship between step length and wavelength shift of Dip 2.

The microdisplacement experiment is carried out at room temperature. In order to guarantee the service life of the sensor due to excessive tensile fracture and prevent the sensor structure, the range of measuring is from 17.22 mm to 17.70 mm, and the step length is 0.06 mm (using vernier caliper to control the displacement and the precision of the vernier caliper is 0.02 mm). The output spectra and microdisplacement response characteristics curve are shown in Fig. 8.

By increasing the distance of the vernier caliper, the transmission spectrum produces a corresponding wavelength shift. Compared with the change of light intensity, the linearity of the drift amount of the wavelength is better. From Fig. 8(b), we can see that the microdisplacement sensitivities of Dip 1 and Dip 2 are 2017.71 pm/mm and 2457.92 pm/mm, respectively.

3.3 Results and discussion

It could be concluded that the microdisplacement and temperature sensitivities of the two dips are different from the above experimental results. The relationship between the shifts of Dip 1, Dip 2, temperature, and microdisplacement can be expressed in matrix form as

$$\begin{bmatrix} \Delta \lambda_{B1} \\ \Delta \lambda_{B2} \end{bmatrix} = \begin{bmatrix} K_{T1} & K_{I1} \\ K_{T2} & K_{I2} \end{bmatrix} \begin{bmatrix} \Delta T \\ \Delta I \end{bmatrix}$$
 (10)

where $\Delta \lambda_{B1}$ and $\Delta \lambda_{B2}$ are the shifts of the Dip 1 and Dip 2, respectively, ΔT is the change of temperature, Δh is the value of microdisplacement, K_{T1} and K_{T1} are the temperature and microdisplacement sensitivities of Dip 1, and K_{T2} and K_{I2} are the temperature and microdisplacement sensitivities of Dip 2.

All the sensitivity coefficients can be obtained from the experimental results. We can use a sensitivity matrix to obtain the variation of temperature and microdisplacement. The relationship is given as

$$\begin{bmatrix} \Delta T \\ \Delta I \end{bmatrix} = \frac{1}{D} \begin{bmatrix} K_{12} & -K_{11} \\ -K_{T2} & K_{T1} \end{bmatrix} \begin{bmatrix} \Delta \lambda_{B1} \\ \Delta \lambda_{R2} \end{bmatrix}$$
(11)

where $D = K_{T1}K_{12} - K_{T2}K_{11}$.

Then substitute the experimental data into (10)

and get the following equation:

$$\begin{bmatrix} \Delta T \\ \Delta I \end{bmatrix} = \frac{1}{4.9 \times 10^8} \begin{bmatrix} 2457.92 & -2017.71 \\ -89.72 & 98.65 \end{bmatrix} \begin{bmatrix} \Delta \lambda_{B1} \\ \Delta \lambda_{B2} \end{bmatrix} . (12)$$

The sensor structure is subject to external factors (such as temperature and microdisplacement) and the transmission spectrum causes a corresponding wavelength shift. Temperature and microdisplacement can be further obtained by obtaining the corresponding wavelength drift of the transmission spectrum trough (i.e., $\Delta \lambda_{B1}$ and $\Delta \lambda_{B2}$), thereby the measurement of temperature and microdisplacement can be achieved simultaneously.

It can be known from (11) that if the sensitivities fiber sensor to of temperature and microdisplacement changes known, the are wavelength change of the transmission spectrum can be monitored by a spectrometer and substituted into (11) for calculation. In the actual solution calculation, the difference in sensitivity coefficient between the two sets of fiber structures is greater and the sensing of temperature and microdisplacement is more reliable.

Compared with the early MZI structure [17–19], the proposed sensor in this paper has a shorter structure and deeper interference valley. In terms of the manufacturing process of different MZI structures, the proposed SMF-ball-SCF-ball-SMF sensor structure has a simpler manufacturing process and the length of the MZI is more controllable. Compared with the tapering MZI sensor [17], the proposed sensor has better reliability and strength.

4. Conclusions

In this paper, an all-fiber MZI sensor based on a seven-core fiber and two single-mode fiber balls is proposed and investigated for simultaneously measuring temperature and microdisplacement.

The experimental results show that under the external environment, the MZI interference structure in the paper changes the output light intensity, and the transmission spectrum causes a corresponding

wavelength shift. The sensitivity of the sensor for the temperature of the two dips are 98.65 pm/°C and 89.72 pm/°C, respectively. And the sensitivities of the sensor for the microdisplacement are 2017.71 pm/mm and 2457.92 pm/mm, respectively.

Compared with other interferometric sensors of the MZI structure, this structure has advantages of simple production process, high reliability, and better strength. The sensor will have broad applications in the field of automation equipment, robots, and the management of roads and bridges.

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